

### PHASE CONTROL THYRISTORS

- Junction Size : Square 180 mils - IR180SH12H/ S1231
- Wafer Size : 4"
- $V_{RRM}/V_{DRM}$  Class : 1200 V
- Passivation Process : Glassivated MESA
- Reference IR Packaged Part : n. a.

### Major Ratings and Characteristics

| Parameters                                        | Units       | Test Conditions                                                   |
|---------------------------------------------------|-------------|-------------------------------------------------------------------|
| $V_{TM}$ Typical On-state Voltage                 | 1.3 V       | $T_J = 25^\circ\text{C}$ , $I_T = 25\text{ A}$                    |
| $V_{RRM}/V_{DRM}$ Reverse Breakdown Voltage       | 1200V       | $T_J = 25^\circ\text{C}$ , $I_{RRM} = 300\text{ }\mu\text{A}$ (1) |
| $I_{GT}$ Required DC Gate Current to Trigger      | 5 to 45 mA  | $T_J = 25^\circ\text{C}$ , anode supply = 6 V, resistive load     |
| $V_{GT}$ Max. Required DC Gate Voltage to Trigger | 1.9 V       | $T_J = 25^\circ\text{C}$ , anode supply = 6 V, resistive load     |
| $I_H$ Holding Current Range                       | 5 to 150 mA | Anode supply = 6 V, resistive load                                |
| $I_L$ Maximum Latching Current                    | 400 mA      | Anode supply = 6 V, resistive load                                |

(1) Nitrogen flow on die edge.

### Mechanical Characteristics

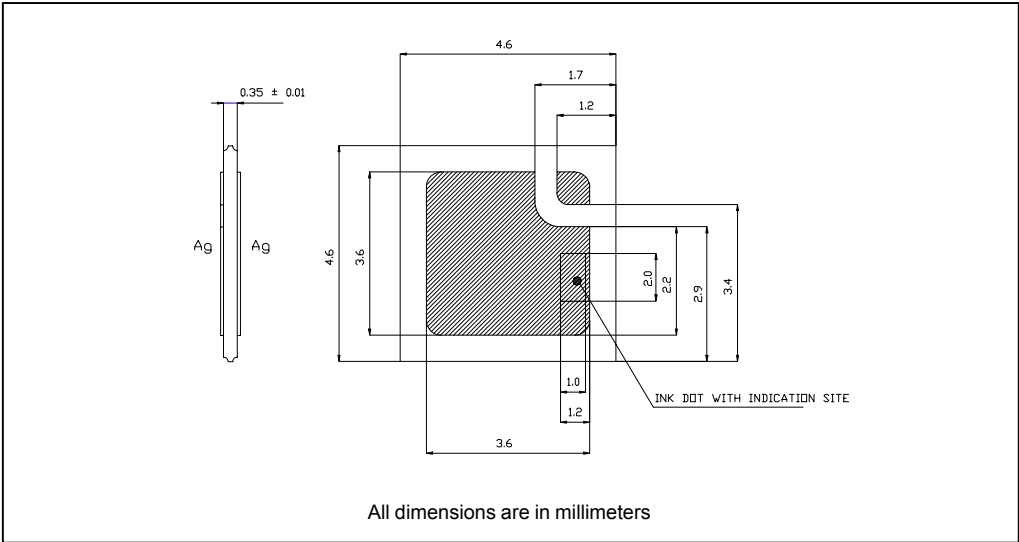
|                                            |                                                                              |
|--------------------------------------------|------------------------------------------------------------------------------|
| Nominal Back Metal Composition, Thickness  | Cr - Ni - Ag (1 KA - 4 KA - 15 KA)                                           |
| Nominal Front Metal Composition, Thickness | Cr - Ni - Ag (1 KA - 4 KA - 15 KA)                                           |
| Chip Dimensions                            | 180 x 180 mils (see drawing)                                                 |
| Wafer Diameter                             | 100 mm, with std. < 100 > flat                                               |
| Wafer Thickness                            | 350 $\mu\text{m} \pm 10\text{ }\mu\text{m}$                                  |
| Maximum Width of Sawing Line               | 130 $\mu\text{m}$                                                            |
| Reject Ink Dot Size                        | 0.25 mm diameter minimum                                                     |
| Ink Dot Location                           | See drawing                                                                  |
| Recommended Storage Environment            | Storage in original container, in dessicated nitrogen, with no contamination |

# S1231

Bulletin I0143J 01/01

International  
**IRF** Rectifier

## Outline Table



## Wafer Layout

